





## Substitute for form 1449A/PTO Substitute for form 1449A/PTO

(use as many sheets as necessary)

1 of ı Sheet

Complete if Kn wn			
Application Number	09/753,256		
Filing Date	December 28, 2000		
First Named Inventor	Valery M. Dubin		
Art Unit	2813		
Examiner Name	Nguyen, Tuan H.		
Attorney Docket Number	42390P10254		

	OTHER ART - NON PATENT LITERATURE DOCUMENTS				
	Examiner Initials*  Cite No.*  Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.				
ア	N		Osaka, et al., "Preparation of CoB Soft Magnetic Thin Films by Electroless Plating," IEEE Translation Journal on Magnetics in Japan, Vol. 6, No. 1, January 1991, pp. 85-90.		
T	1		Watanabe, et al., "Direct Electroless Nickel Plating on Copper Circuits Using DMAB as a Second Reducing Agent, " 1998 IEMT/IMC Proceedings, pp. 149-153.		
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Examiner Date NAMEN Signature Considered

\*Examiner: Initial 8 reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation 6 not in conformance and not considered. Include copy of this form with next communication.

<sup>1</sup>Applicant's unique citation designation number. <sup>2</sup>Applicant is to place a check mark here it English language Translation is attached.

Besed on PTO/SB/088 (05-03) as modified by Blakely, Sclokoff, Teylor & Zetman (w/r) 05/02/2003. Send Τα: Commissioner for Patents. P.O. Box 1450, Alexandria, VA 22313-1450



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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

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Tal		Dubin, et al., "Selective Electroless Ni Deposition onto Pd-Activated Si for Integrated Circuit Fabrication," Thin Solid Films, 226, 1993, pp. 94-98	
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Ł	Examiner Signature	T. NGWEN	Date Considered	9/17/03

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